

Confirmation no. 3423

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DE BOER	Examiner:	Lund, J.
Serial No.:	10/537,363	Group Art Unit:	1792
Filed:	June 2, 2005	Docket No.:	US020527US (NXPS.441PA)
Title:	SYSTEM AND METHOD FOR SUPPRESSION OF WAFER TEMPERATURE DRIFT IN COLD-WALL CVD SYSTEMS		

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

In response to the non-final Office Action dated April 30, 2009, please consider the following response.

A complete listing of the Claims and Remarks/Arguments follow.

A Petition for a Two Month Extension of time to file accompanies this paper.